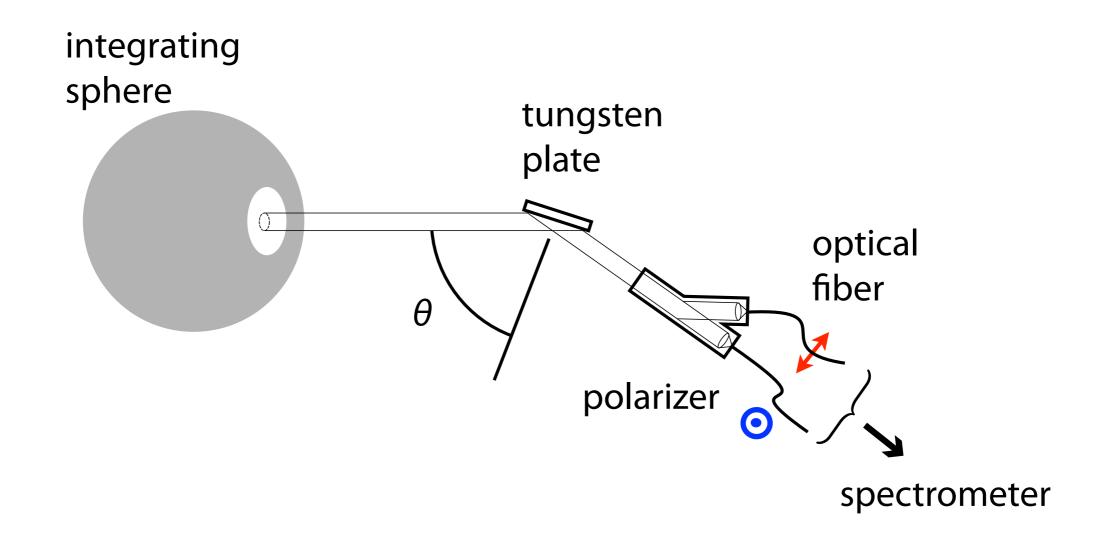
Evaluation of optical parameters for tungsten from polarized thermal radiation

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- Kirchhoff's law stipulates a relationship between reflectance and emissivity
- reflectance of dielectric material has polarization dependence, so emissivity should also

reflectance measurement

optical constants are determined from dependence of reflected light on polarization



measured 8.0 reflectance 0.6 0.4 30 60 90 incidence angle (digrees)

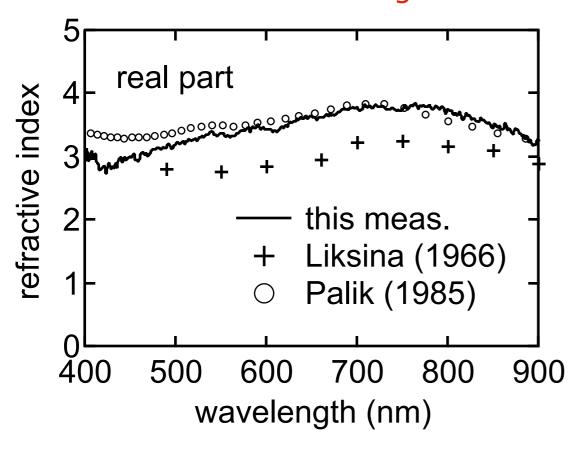
Fresnel equation

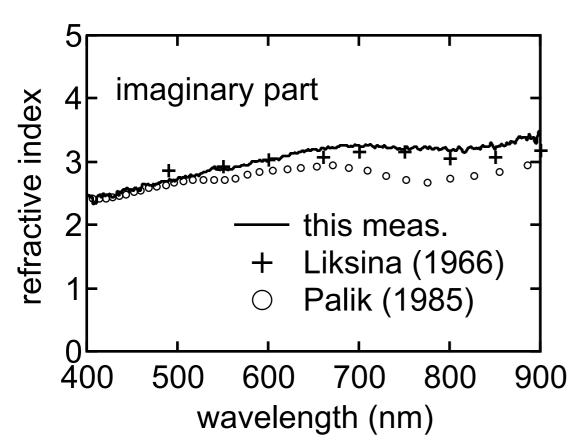
$$R_{\parallel} = \left| \frac{\hat{n}^2 \cos \theta - \sqrt{\hat{n}^2 - \sin^2 \theta}}{\hat{n}^2 \cos \theta + \sqrt{\hat{n}^2 - \sin^2 \theta}} \right|^2$$

$$R_{\perp} = \left| \frac{\cos \theta - \sqrt{\hat{n}^2 - \sin^2 \theta}}{\cos \theta + \sqrt{\hat{n}^2 - \sin^2 \theta}} \right|^2$$

$$\hat{n} = n + i\kappa$$

refractive index for tungsten





refractive index may depend on temperature

same method is difficult to use for high temperature case

can thermal radiation be instead used?

reflectance = 1 - emissivity

$$\left(\begin{array}{c}
\text{emissivity} = \frac{\text{thermal rad.}}{\text{black-body}}\right)$$

ACT (Active Cooling Teststand)

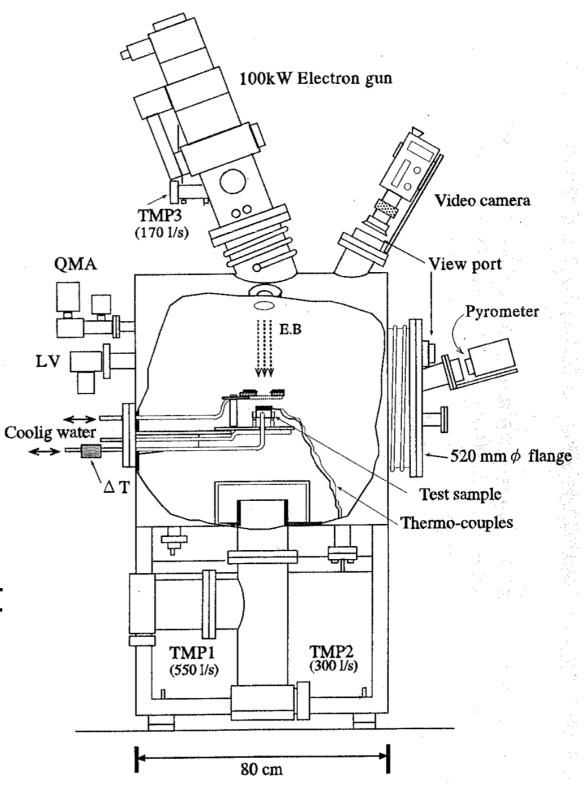
voltage 30 kV

current 3.3 A (max)

irradiated area 1-400 cm²

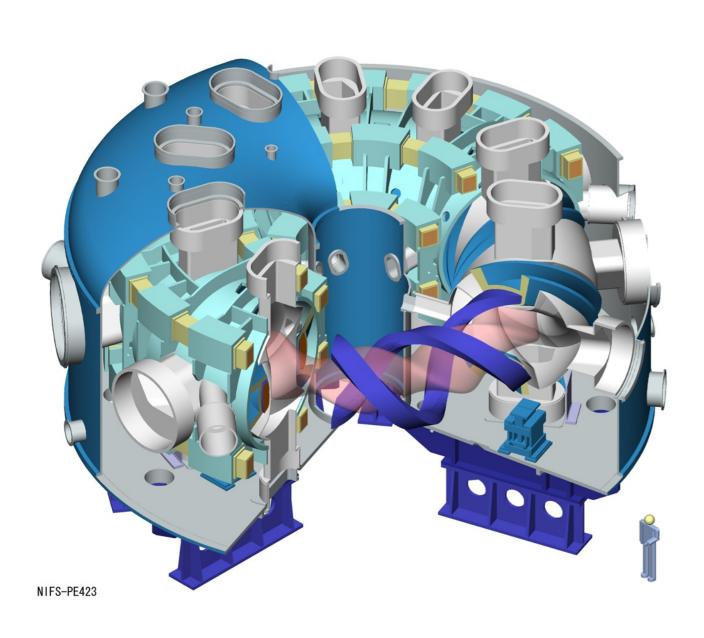
heat load on target 0-100 MW/m²

used for material development for divertor plates in fusion device



LHD (Large Helical Device)

specifications



major radius 3.5 - 4.2 m

minor radius 0.6 m (avg.)

magnetic field < 3 T

plasma volume ~ 30 m³

achievements

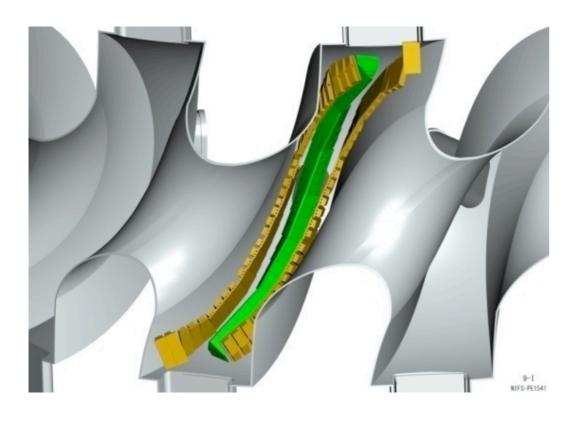
 $P_{\text{in}} = 20 \text{ MW}$

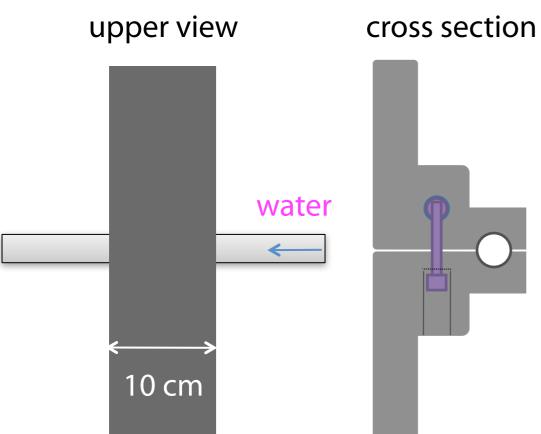
 $T_{\rm e} = 15 \, {\rm keV}$

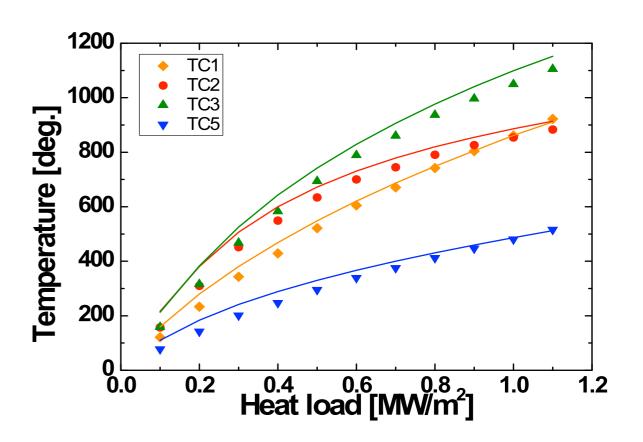
 $T_{\rm i} = 13 \, {\rm keV}$

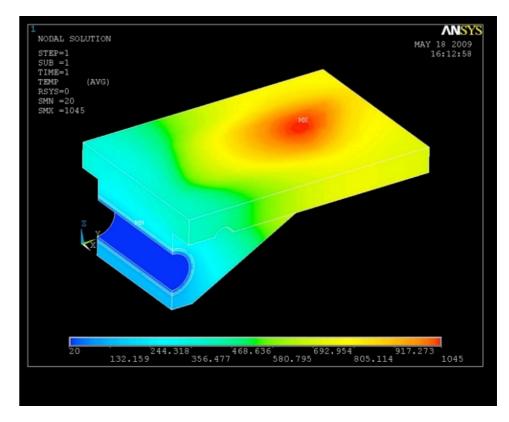
 $n_{\rm e} = 1 \times 10^{21} \, {\rm m}^{-3}$

temperature distribution analysis in material

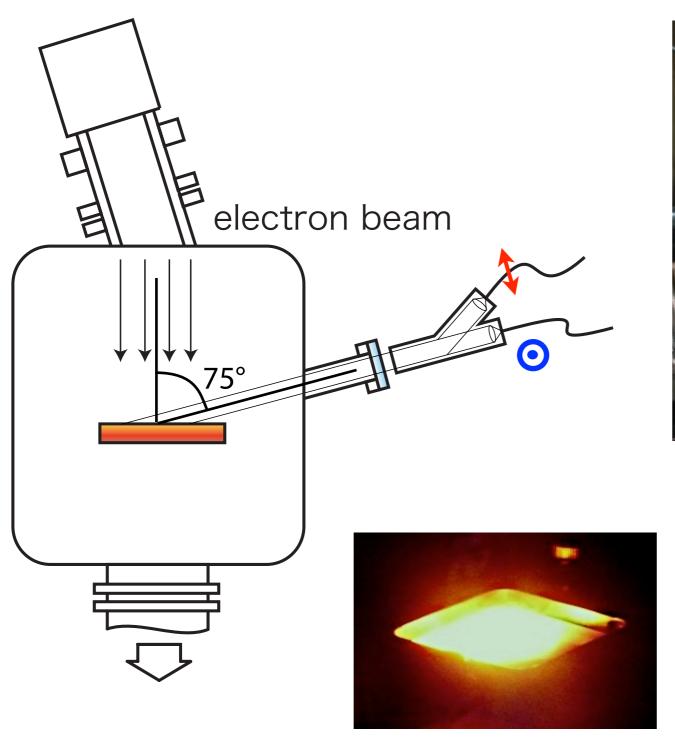


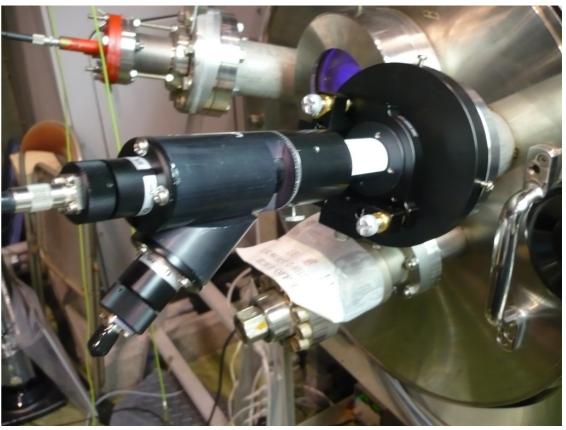






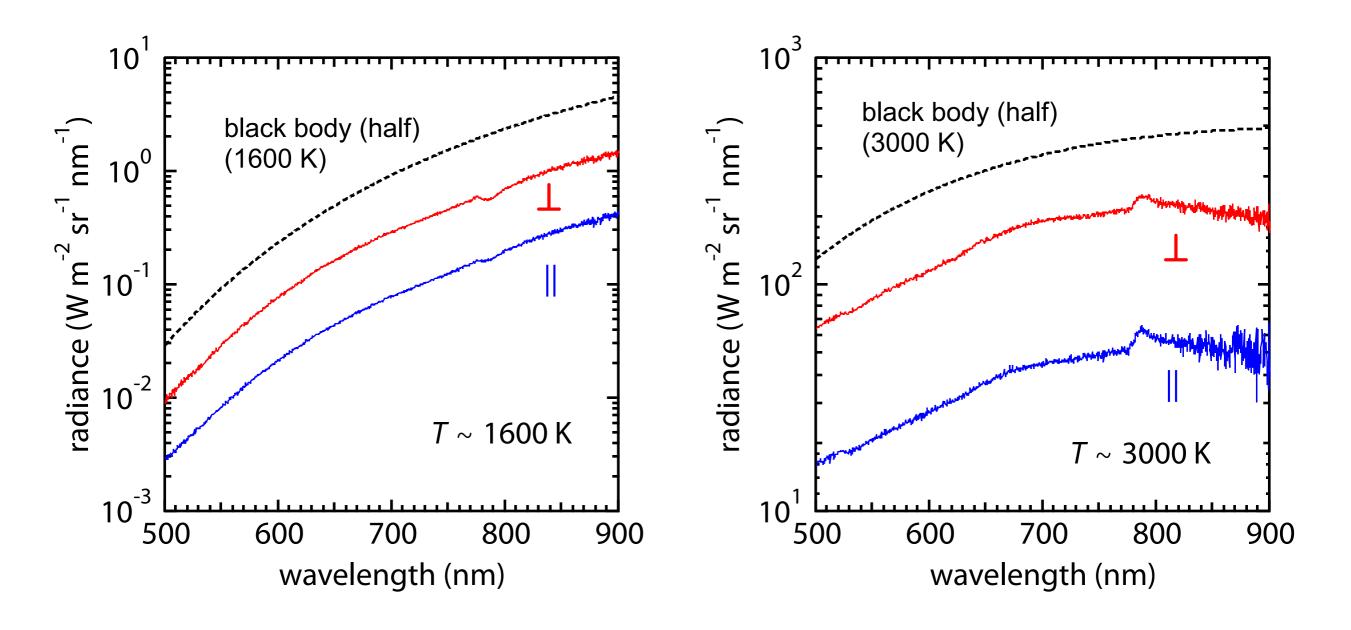
thermal radiation measurement





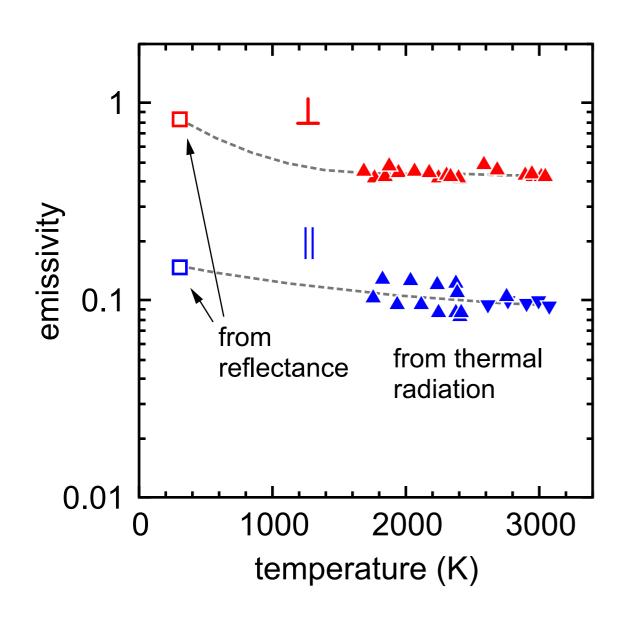
polarization resolved measurement

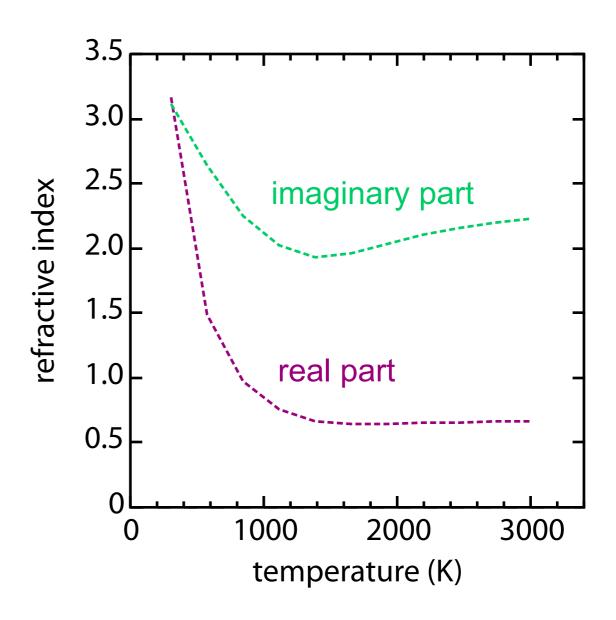
polarizability dependence of thermal radiation



temperature and emissivity are simultaneously determined from fitting of measured spectrum (constant λ dependence is assumed)

emissivity and refractive index



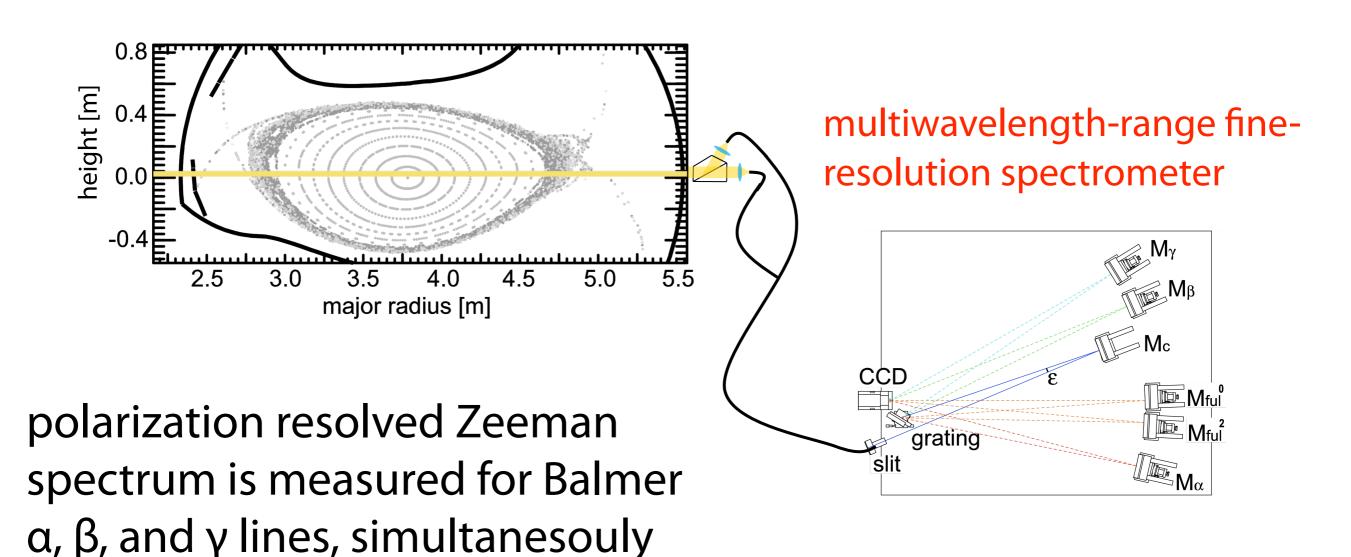


 polarized thermal radiation is clearly observed

 refractive index is derived from emissivity and Kirchhoff's law

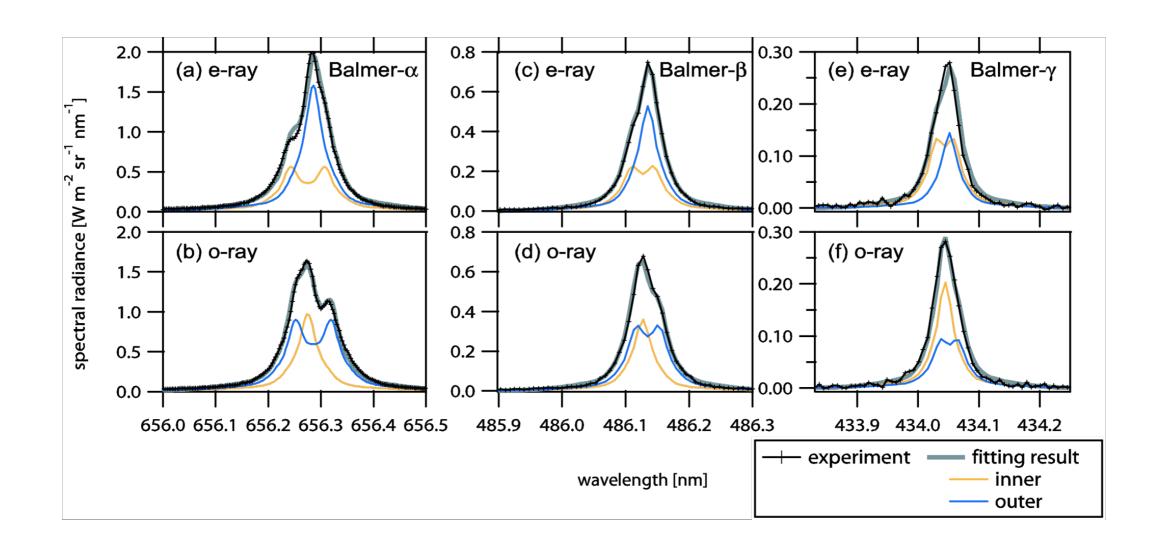
independent temperature measurement is required

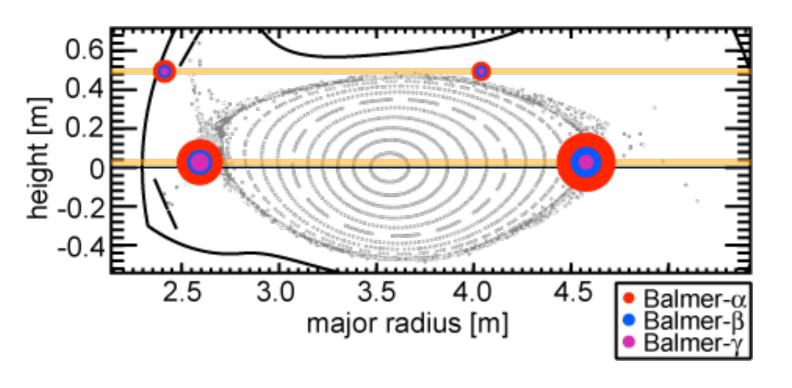
emission location measurement



profile → emission location

intensities \rightarrow plasma parameters (T_e, n_e)





emission location is determined with accuracy parameter measurement is under way